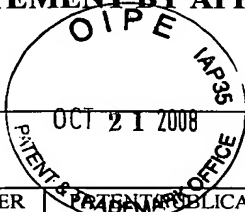


INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	Docket No. 52433/795	Application No. 10/534,858	
	Applicant(s) HASHIMURA et al.	Examiner Deborah Yee	
	Filing Date May 13, 2005	Confirmation No. 9080	Art Unit 1793



U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	2002-249823	09/06/2002	JP			Abstract	
	11-293391	10/26/1999	JP			Abstract	
	2002-3991	01/09/2002	JP			Abstract	
	2000-160284	06/13/2000	JP			Abstract	
	2000-319753	11/21/2000	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated September 12, 2008 issued in corresponding Japanese Application No. 2003-374489.
	Japanese Office Action dated September 12, 2008 issued in corresponding Japanese Application No. 2003-374517.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	